

AF/IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of:

Applicant: Raghu Raghavan et al.
Serial No.: 09/745,039
Filing date: December 20, 2000
Title: METHOD FOR DYNAMIC CHARACTERIZATION OF DENSITY FIELDS
IN A COMPOUND STRUCTURE
Examiner: Tom Y. Lu
Art Unit: 2621
Docket No. SCHWP0209US (formerly 723.100US1)

REPLY TO OFFICE ACTION DATED SEPTEMBER 23, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Favorable reconsideration of the above-referenced application is respectfully requested in view of the following part(s) of this reply:

Amendments to the Claims

Remarks

Enclosures: Credit card payment form
 Petition for Extension of Time
 Information Disclosure Statement

In the event any fee or additional fee is due in connection with the filing of this paper, the Commissioner is authorized to charge those fees to our Deposit Account No. 18-0988 (under the above Docket Number). In the event an extension of time is needed to make the filing of this paper timely and no separate petition is attached, please consider this a petition for the requisite extension and charge the fee to our Deposit Account No. 18-0988 (under the above Docket Number).